



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

December 19, 2025

IGI Report Number **LG756512275**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **ROUND BRILLIANT**

Measurements **12.20 - 12.25 X 7.58 MM**

GRADING RESULTS

Carat Weight **7.05 CARATS**

Color Grade **E**

Clarity Grade **VVS 2**

Cut Grade **IDEAL**

ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG756512275**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.

Type Ila

LG756512275
Report verification at igi.org

LABORATORY GROWN DIAMOND REPORT



December 19, 2025

IGI Report Number **LG756512275**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **ROUND BRILLIANT**

Measurements **12.20 - 12.25 X 7.58 MM**

GRADING RESULTS

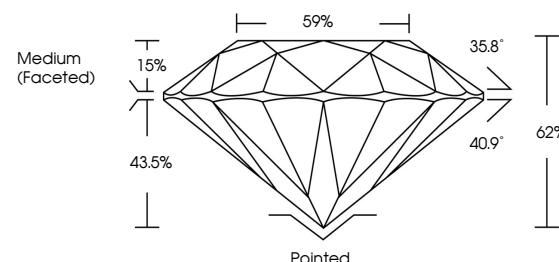
Carat Weight **7.05 CARATS**

Color Grade **E**

Clarity Grade **VVS 2**

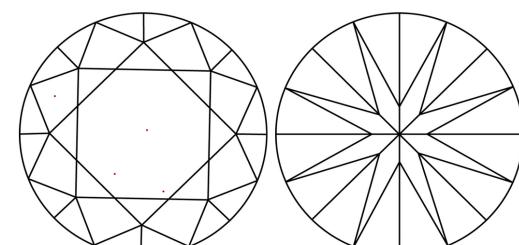
Cut Grade **IDEAL**

PROPORTIONS



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light
---	---	---	---	---	---	---	-------	------------	-------

CLARITY

FL	IF	VS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
----	----	-------------------	-------------------	-------------------	------------------

Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included
----------	---------------------	-----------------------------	------------------------	-------------------	----------

ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG756512275**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.

Type Ila

www.igi.org

© IGI 2020, International Gemological Institute



IGI

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.

Type Ila